



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Tilke et al.)	Group Art Unit: 2811
)	
Attorney Docket No. 1890-0061)	Confirmation No.: 7063
)	
Application No.: 10/780,276)	Examiner: Thien F. Tran
)	
Filed: February 17, 2004)	
)	
For: Semiconductor Structure With)	
Increased Breakdown Voltage and)	
Method for Producing the)	
Semiconductor Structure)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENT & RESPONSE

Sir:

In response to the Office action of May 3, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.